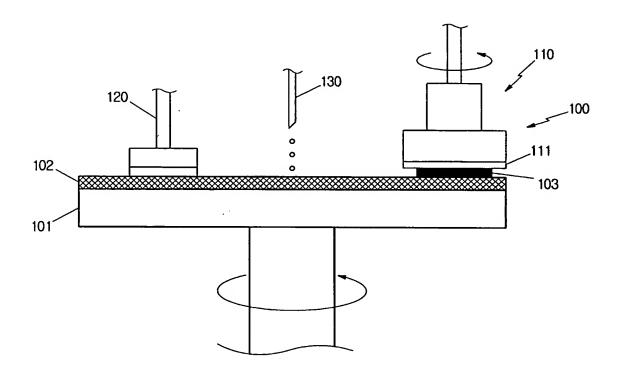
Inventor: Ji Myong LEE
For: "Apparatus and Methods of Chemical Mechanical Polishing"
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FIG. 1 (RELATED ART)



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FIG. 2

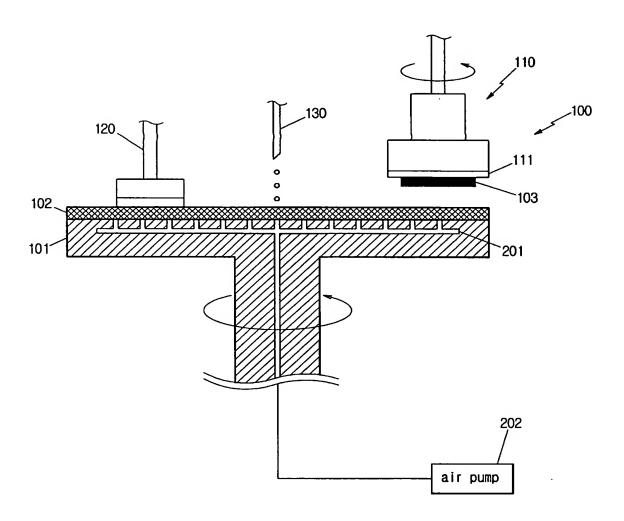
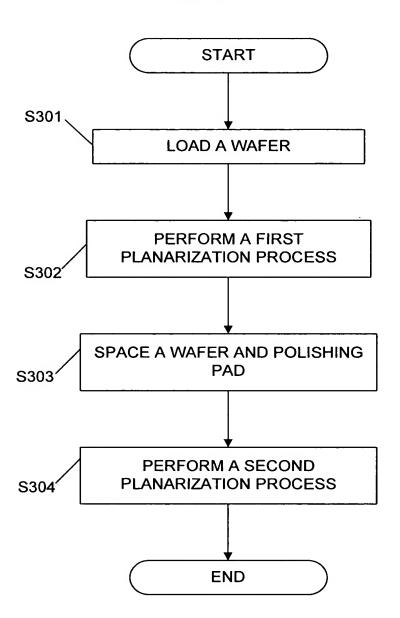


FIG. 3



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FIG. 4

